

**Search Notes**

Application/Control No.

10/617,198

Examiner

Jacob Y. Choi

Applicant(s)/Patent under  
Reexamination

KENYA UOMORI

Art Unit

2875

**SEARCHED**

Class	Subclass	Date	Examiner
362	11, 233, 315, 276, 802, 234	3/30/2005	JC
362	249, 251	3/30/2005	JC
362	250	3/30/2005	JC
315	151, 152	3/30/2005	JC
315	158	3/30/2005	JC
356	3.12, 3.1	3/30/2005	JC
356	4.01	3/30/2005	JC
* ALL	ALL	10/14/2005	JC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Class/Subclass Search 362 & 315 - Alan Cariaso	3/30/2005	JC
Text Search Conducted by Examiner	10/14/2005	JC